

FORM PTO-1449		US Dept. of Commerce Patent and Trademark Office		ATTORNEY DOCKET NO. ATMI-537-CIP	SERIAL NO. 10/632,009	
INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)				APPLICANT Chongying Xu, et al.	DEC 24 2003 U. S. PATENT & TRADEMARK OFFICE	
				FILING DATE July 31, 2003	GROUP 2812 2818	

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PD	AA	5,840,897	11/24/1998	Kirlin, et al.	—	—	—
	AB	5,453,494	9/26/1995	Kirlin, et al.	—	—	—
	AC	6,110,529	8/29/2000	Gardiner, et al.	—	—	—
	AD	5,820,664	3/31/1995	Gardiner, et al.	—	—	—
	AE	5,225,561	9/12/1990	Kirlin, et al.	—	—	—
	AF	5,789,027	8/4/1998	Watkins, et al.	—	—	—
	AG	6,576,345 B1	6/10/2003	Van Cleemput, et al.	—	—	—
	AH	5,211,342 A	5/18/1993	Hoy, et al.	—	—	—
	AI	6,207,522 B1	3/27/2001	Hunt, et al.	—	—	—
PD	AJ	10/632,009		Chongying Xu, et al.	—	—	11/25/2002

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES	NO
							X (abstract only)	

## OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)

PD	AK	Brian N. Hansen, et al., "Supercritical Fluid Transport-Chemical Deposition of Films" Chemical Materials, 1992, 4, 749-752.
PD	AL	Jason M. Blackburn, et al., "Deposition of Conformal Copper and Nickel Films from Supercritical Carbon Dioxide" Science, Vol 294, October 5, 2001, pgs. 141-145
PD	AM	C.Y. Xu, et al., "Supercritical Carbon Dioxide Assisted Aerosolization for Thin Film Deposition, Fine Powder Generation, and drug delivery", Green Chemistry, Editors: Anastas, Paul T., et al. Oxford University Press, Oxford, UK, pgs. 312-335.

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EXAMINER	DATE CONSIDERED
PHUOC T. DANG	11/19/2004

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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**SUPPLEMENTAL  
INFORMATION  
DISCLOSURE STATEMENT  
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Sheet 1 of 1

Examiner signature	PHU C T. DANG	Date Considered	05/05/05
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<sup>1</sup> All the foreign patents and publications that are not written in English language are accompanied by their respective English abstracts, which constitute concise explanation of relevance of the non-English patents and publications that satisfy the requirements of 37 C.F.R. §1.98(a)(3)(i), according to MPEP 609 III A(3).